

INFORMATION DISCLOSURE CITATION IN AN APPLICATION

(Use several sheets if necessary)

 Attorney Docket No.:
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 Application No.:
10/815,949

 Applicant:
Kenichiro YAGAWA

 Filing Date:
April 2, 2004

Group Art Unit:

U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing date (if appropriate)
	2003/0027597	2/6/2003	LA GROTTA et al.			

FOREIGN PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Country	Class	Subclass	Translation	
						Yes	No

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

Office Action from German Patent Office with English translation issued on August 1, 2007
 "ERICSSON: Recapitulation of the IPDL positioning method", April 18-20, 1999, 10 pages, TSG-RAN Working Group 1 meeting #4, TSGR 1#4(99)346.

EXAMINER:

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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.

* English language abstract provided for the Examiner's convenience

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